



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Isaac Ostrovsky, et al.  
Appl. No. : 10/017,534  
Filing Date : October 18, 2001  
Title : DIFFRACTION GRATING BASED INTERFEROMETRIC SYSTEMS AND METHODS  
Group Art Unit : 2877  
Examiner : Patrick J. Connolly  
Docket No. : 701470.19 (formerly 265/222)

Mail Stop **NON FEE AMENDMENT**  
Commissioner for Patents  
PO Box 1450  
Alexandria, Virginia 22313-1450

TECHNOLOGY CENTER 2950  
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**RESPONSE TO OFFICE ACTION**

Sir:

In response to the Office Action mailed July 14, 2003, Applicants respond as follows:

Attorney Docket Number

Please note that our Attorney Docket Number has been changed to 701470.19.

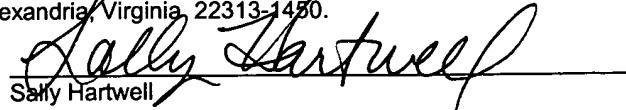
Applicants respectfully request that this number be referenced in all future correspondence.

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**CERTIFICATE OF MAILING (37 CFR §1.8)**

I hereby certify, pursuant to 37 CFR §1.8, that I have reasonable basis to expect that this paper or fee (along with any referred to as being attached or enclosed) would be mailed or transmitted on or before the date indicated with the United States Postal Service with sufficient postage as first class mail on the date shown below in an envelope addressed to Commissioner for Patents, PO Box 1450, Alexandria, Virginia 22313-1450.

Dated: September 18, 2003

  
Sally Hartwell